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09/539,313 03/30/2000		Chung-Ho Huang	LAM1P136/P0602	7930
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BEYER WEA	AVER & THOMAS LLP	EXAMINER		
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			2143 DATE MAILED: 04/07/2003	8

Please find below and/or attached an Office communication concerning this application or proceeding.

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•		Application No.	Applicant(a)	—∂		
Office Action Summany		Application No.	Applicant(s)			
		09/539,313	HUANG ET AL.			
	Office Action Summary	Examin r	Art Unit			
		David E. England	2143			
Period fo	The MAILING DATE of this communication app or Reply	ars on the c v r sheet with the	correspondenc addr ss			
THE - Exte after - If the - If NO - Failu - Any I	ORTENED STATUTORY PERIOD FOR REPL' MAILING DATE OF THIS COMMUNICATION. nsions of time may be available under the provisions of 37 CFR 1.1: SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period v re to reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing ad patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be y within the statutory minimum of thirty (30) d will apply and will expire SIX (6) MONTHS fro , cause the application to become ABANDON	timely filed ays will be considered timely. om the mailing date of this communication. VED (35 U.S.C. § 133).	,		
1)🛛	Responsive to communication(s) filed on 28 /	<u> May 2002</u> .				
2a) <u></u> □	This action is FINAL. 2b)⊠ Th	is action is non-final.				
3) 🗌	Since this application is in condition for allowed closed in accordance with the practice under					
•	ion of Claims					
-	Claim(s) <u>1-15</u> is/are pending in the application					
	4a) Of the above claim(s) is/are withdray	wn from consideration.				
	· · · · · · · · · · · · · · · · · · ·					
	Claim(s) <u>1-9</u> is/are rejected.					
·	Claim(s) is/are objected to.	ala etian maguiramant				
,	Claim(s) <u>1-15</u> are subject to restriction and/or of the companies on Papers	election requirement.	•			
·· _	The specification is objected to by the Examine	r.				
,	The drawing(s) filed on is/are: a)☐ accep		aminer.			
,	Applicant may not request that any objection to the					
11)[The proposed drawing correction filed on					
	If approved, corrected drawings are required in rep	oly to this Office action.				
12)	The oath or declaration is objected to by the Ex	aminer.				
Priority ι	under 35 U.S.C. §§ 119 and 120					
13)	Acknowledgment is made of a claim for foreign	n priority under 35 U.S.C. § 119	(a)-(d) or (f).			
a)	☐ All b)☐ Some * c)☐ None of:					
	1. Certified copies of the priority document	s have been received.				
	2. Certified copies of the priority document	s have been received in Applica	ation No			
* (3. Copies of the certified copies of the prior application from the International Bu See the attached detailed Office action for a list	reau (PCT Rule 17.2(a)).				
14) 🗌 A	Acknowledgment is made of a claim for domesti	c priority under 35 U.S.C. § 119	e) (to a provisional application)	۱.		
)					
Attachmen	t(s)					
2) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s) <u>2</u>	5) Notice of Informa	ary (PTO-413) Paper No(s)			
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DETAILED ACTION

1. Claims 1 - 15 are presented for examination.

Election/Restrictions

1. Applicant's election with traverse claims 1 - 9 from the claims of 1 - 15.

Claim Rejections - 35 USC § 112

1. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

- 2. Claim 1 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- 3. The limitation of, "initializing the first sensor, which is able to measure a first parameter in the process chamber", is not described in the specification.

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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- 2. Claim 1 is rejected under 35 U.S.C. 103(a) as being unpatentable over Kail (6225901) in view of Nakamura et al. (6233492) (hereinafter Nakamura).
- 3. As per claim 1, Kail teaches a computer implemented method for communicating between a computing system of a process module, and a first sensor, comprising the steps of:
- 4. initializing the computing system of the process module, (e.g. col. 6, line 49 col. 7, line 20);
- 5. transmitting a connect message from the first sensor to the computing system of the process module, (e.g. col. 6, line 49 col. 7, line 20);
- 6. transmitting a command to get reportable specification from the computing system of the process module to the first sensor, (e.g. col. 6, line 49 col. 7, line 59); and
- 7. transmitting a reportable specification message from the first sensor to the computing system of the process module, (e.g. col. 7, line 21 col. 8, line 28). Kail does not teach the process module having a process chamber, initializing the first sensor, which is able to measure a first parameter in the process chamber. Nakamura teaches the process module having a process chamber, initializing the first sensor, which is able to measure a first parameter in the process chamber, (e.g. col. 3, line 35 col. 4, line 67). It would be obvious to one skilled in the art at the time the invention was made to combine Nakamura with Kail because it would be more efficient for the computing system to utilize a network type connection so the user can operate the sensor and process chamber form different locations in a building.
- 8. Claim 2 is rejected under 35 U.S.C. 103(a) as being unpatentable over Kail (6225901) in view of Nakamura (6233492) in further view of Steen, III et al. (6510350) (hereinafter Steen) in further view of Kosugi et al. (6204768) (hereinafter Kosugi).

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- 9. As per claim 2, Kail and Nakamura do not specifically teach spawning within the computing system of the process module a connection monitor task;
- 10. spawning from the connection monitor task within the computing system of the process module a first sensor messaging task;
- 11. transmitting an acknowledgement of the command to get reportable specification from the first sensor to the computing system of the process module; and
- 12. transmitting an acknowledgement of the reportable specification message from the computing system of the process module to the first sensor. Steen teaches spawning within the computing system of the process module a connection monitor task, (e.g. col. 11, line 4 col. 12, line 21);
- spawning from the connection monitor task within the computing system of the process module a first sensor messaging task, (e.g. col. 11, line 60 col. 12, line 56);
- 14. transmitting an acknowledgement of the command to get reportable specification from the first sensor to the computing system of the process module, (e.g. col. 9, line 63 col. 10, line 29). It would be obvious to one skilled in the art at the time the invention was made to combine Steen with the combine system of Kail and Nakamura because
- 15. Steen does not specifically teach transmitting an acknowledgement of the reportable specification message from the computing system of the process module to the first sensor. Kosugi teaches transmitting an acknowledgement of the reportable specification message from the computing system of the process module to the first sensor, (e.g. col. 8, lines 28 48). It would be obvious to one skilled in the art at the time the invention was made to combine Kosugi with the combine system of Kail and Nakamura because it would be more efficient for a system to utilize the properties of an acknowledgement signal so in case of a bad transmission the sensor would know that the computing system did or did not get the signal and to retransmit the signal.

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- 16. Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Kail (6225901) in view of Nakamura (6233492) in further view of Steen (6510350) in further view of Kosugi (6204768) in further view of Dewar et al. (4645348) (hereinafter Dewar).
- 17. As per claim 3, Kail and Nadamura do not specifically teach transmitting command to get an alarm table command from the first sensor to the computing system of the process module;
- 18. transmitting an acknowledgement of the command to get the alarm table from the computing system of the process module to the first sensor;
- transmitting an alarm table from the computing system of the process module to the first sensor; and 19.
- 20. transmitting an acknowledgement of the alarm table from the first sensor to the computing system of the process module. Dewar teaches transmitting command to get an alarm table command from the first sensor to the computing system of the process module, (e.g. col. 6, lines 31 - 44);
- 21. transmitting an alarm table from the computing system of the process module to the first sensor, (e.g. col. 6, lines 31 – 44). It would be obvious to one skilled in the art at the time the invention was made to combine Dewar with the combine system of Kail and Nakamura because it would be more efficient for a system to transmit one alarm table to and from the computing system and the first sensor and having the sensor update the table as opposed to sending multiple packets of data throughout the system with a potential to cause slow transmission in the system.
- 22. Dewar does not specifically teach transmitting an acknowledgement of the command to get the alarm table from the computing system of the process module to the first sensor;
- 23. transmitting an acknowledgement of the alarm table from the first sensor to the computing system of the process module. Kosugi teaches transmitting an acknowledgement of the command to get the alarm table from the computing system of the process module to the first sensor, (e.g. col. 8, lines 28 - 48), and Steen teaches

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transmitting an acknowledgement of the alarm table from the first sensor to the computing system of the process module, (e.g. col. 9, line 63 – col. 10, line 29). It would be obvious to one skilled in the art at the time the invention was made to combine Kosugi and Steen with the combine system of Kail, Nakamura and Dewar because if the computing system and the first sensor could not acknowledge each others transmissions the system could accumulate transmission errors and improper updating of the measurements that the sensor detects.

- Claims 4 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kail (6225901) in view of Nakamura (6233492) in further view of Steen (6510350) in further view of Kosugi (6204768) in further view of Dewar (4645348) in further view of Halpern (5301122).
- 25. As per claim 4, Kail, Nakamura and Dewar do not specifically teach transmitting command to get time and initialization data from the first sensor to the computing system of the process module;
- 26. transmitting time and initialization data from the computing system of the process module to the first sensor. Halpern teaches transmitting command to get time and initialization data from the first sensor to the computing system of the process module, (e.g. col. col. 11, lines 13 49);
- transmitting time and initialization data from the computing system of the process module to the first sensor, (e.g. col. col. 11, lines 13 49). It would be obvious to one skilled in the art at the time the invention was made to combine Halpern with the combine system of Kail, Nakamura and Dewar because it would be more efficient in the updating process to have time and initialization data so when the computing system does attempt to update its information the computing system can compare the two different times and initialization datas and to determine which ones are the latest versions of information to save.

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- 28. Halpern does not specifically teach transmitting an acknowledgement of the command to get time and initialization data from the computing system of the process module to the first sensor;
- 29. transmitting an acknowledgement of the time and initialization data from the first sensor to the computing system of the process module. Kosugi teaches transmitting an acknowledgement of the command to get time and initialization data from the computing system of the process module to the first sensor, (e.g. col. 8, lines 28 48), and Steen teaches transmitting an acknowledgement of the time and initialization data from the first sensor to the computing system of the process module, (e.g. col. 9, line 63 col. 10, line 29). It would be obvious to one skilled in the art at the time the invention was made to combine Kosugi and Steen with the combine system of Kail, Nakamura, Dewar and Halpern because of similar reasons as stated above.
- 30. As per claim 5, Kail, Kosugi, Dewar and Halpern do not specifically teach transmitting a process related command related to the execution of an action in the process chamber from the computing system of the process module to the first sensor;
- 31. executing the action in the process chamber, wherein said action relates to the processing of semiconductor related devices; and
- 32. transmitting an acknowledgement of the process related command from the first sensor to the computing system of the process module. Nakamura teaches transmitting a process related command related to the execution of an action in the process chamber from the computing system of the process module to the first sensor, (e.g. col. 3, line 35 col. 4, line 67);
- 33. executing the action in the process chamber, wherein said action relates to the processing of semiconductor related devices, (e.g. col. 3, line 35 col. 4, line 67). It would be obvious to one skilled in the art at the time the invention was made to combine Nakamura with the combine system of Kail, Kosugi, Dewar and Halpern because

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- Nakamura does not specifically teach transmitting an acknowledgement of the process related 34. command from the first sensor to the computing system of the process module. Steen teaches transmitting an acknowledgement of the process related command from the first sensor to the computing system of the process module, (e.g. col. 9, line 63 – col. 10, line 29). It would be obvious to one skilled in the art at the time the invention was made to combine Steen with the combine system of Kail, Nakamura, Kosugi, Dewar and Halpern because of similar reasons as stated above.
- Claims 6 9 are rejected for similar reasons as stated above. Furthermore, in reference to a second and 35. third sensor, Kosugi teaches a second and a third sensor, (e.g. col. 6, lines 3 – 33 & Figure 1). It would be obvious to one skilled in the art at the time the invention was made to combine Kosugi with the combine system of Kail, Nakamura, Steen, Dewar and Halpern because having more then one or two sensors would make a system gather information from different locations at a faster pace then having one sensor having to electronically relocate to a different section of the system to gather information about the system, therefore making the system more efficient.

Conclusion

- 36. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.
- Hwang et al. U.S. Patent No. 6157867 discloses Method and system for on-line monitoring plasma 37. chamber condition by comparing intensity of certain wavelength.
- 38. Straser et al. U.S. Patent No. 6292108 discloses Modular, wireless damage monitoring system for structures.
- 39. Friton et al. U.S. Patent No. 5937365 discloses Communications system for vehicle wheel alignment apparatus.

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Moore U.S. Patent No. 6370454 discloses Apparatus and method for monitoring and maintaining 40.

mechanized equipment.

41. Eastburn et al. U.S. Patent No. 5831851 discloses Apparatus and method for controlling high throughput

sputtering.

42. Sandelman et al. U.S. Patent No. 6535123 discloses Electronic message delivery system.

Wymore U.S. Patent No. 6515586 discloses Tactile tracking systems and methods. 43.

Any inquiry concerning this communication or earlier communications from the examiner should be

directed to David E. England whose telephone number is 703-305-5333. The examiner can normally be

reached on Mon-Thur, 7:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David A.

Wiley can be reached on 703-308-5221. The fax phone numbers for the organization where this application or

proceeding is assigned are none for regular communications and none for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be

directed to the receptionist whose telephone number is none.

David E. England Examiner

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March 31, 2003

SUPERVISORY PATENT EXAMINER

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